ul 16 2 16:25

P. 01

24/2

MOSER, PATTERSON & SHERIDAN, L.L.P.

Attorneys at Law 3040 Post Oak Boulevard, Suite 1500 Houston, Texas 77056-6582 Telephone (713) 623-4844 Facsimile (713) 623-4846 www.mpslip.com

FACSIMILE COVER SHEET

DATE:	July 16, 2002	FILE	FILE NO: AMAT/3049.X			1/CPES/DT/PJS	
TO:	Lan Vinh		FAX NO:	703-872-9310			
COMPANY:	USPTO						
FROM:	Robb Edmonds			PAGE(S): with cover	11		
MESSAGE:				Original to Follow	☐ YES JU	SAR .	
	RESPONSE TO OFFI U.S. Seria Filing Dat Inventor: Group Art	al No. e: : Unit:	09/206		PFF/C/		
	Confirmat Examiner		Lan Vinh				

T:\CLIENTS\APPM\3049.X1\FAX\FAX_EXAMINER.DOC

CONFIDENTIALITY NOTE

The document accompanying this facsimile transmission contains information from the law firm of Moser, Patterson, & Sheridan, L.L.P. which is confidential or privileged. The information is intended to be for the use of the individual or entity named on this transmission sheet. If you are not the intended recipient, be aware that any disclosure, copying, distribution or use of the contents of this faxed information is prohibited. If you have received this facsimile in error, please notify us by telephone immediately so that we can arrange for the retrieval of the original documents at no cost to you.

P 02

PATENT

1/19/08

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

§

のののののののののの

In re Application of:

Cohen, et al.

Serial No.: 09/206,027

Confirmation No.: 4950

Filed:

December 4, 1998

For:

Plasma Preclean With Argon, Helium, and

Hydrogen Gases

BOX AF

Assistant Commissioner for Patents Washington, D.C. 20231

Dear Sir:

Group Art Unit: 1765

Examiner:

L. Vinh PAY RECEI

Atty. Dkt. No. AMAT/3049.X1/CPES/DT/PJS

CERTIFICATE OF FACSIMILE TRANSMISSION UNDER 37 CFR 1.8

I hereby certify that this correspondence and the documents referred to as attached therein are being facsimile transmitted to the U.S. Patent and Trademark Office to the fax number indicated by the Examiner, namely, fax number 703-872-9311 to the attention of the named Examiner, on the date below.

July 16, 2002 7

Signature

RESPONSE TO FINAL OFFICE ACTION DATED MAY 16, 2002

In response to the Office Action dated May 16, 2002, having a shortened statutory period for response set to expire on August 16, 2002, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although Applicant believes that no fee is due in conjunction with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/3049.X1/RDE, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

IN THE CLAIMS:

Please amend claims 32 and 37 as follows:

1. A method for processing a substrate in a processing chamber, comprising exposing a patterned substrate surface to a plasma generated from a gas mixture

Page 1